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U.S. PATENT DOCUMENTS

Examiner Initials*		Document Number	Date	Name	Class	Subclass	Filing Date if Approp.

FOREIGN PATENT DOCUMENTS

Examiner Initials*		Document Number	Date	Country	Class	Subclass	Translation Yes	Translation No
AA		0 903 174 A1	3/24/99	Europe			Abstract	

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Volume-Issue No., Publisher, City where published

B		Angell, et al., "Silicon Micromechanical Devices", SCIENTIFIC AMERICAN, Vol. 248, No. 4, (April, 1983), pgs. 44-55
B		Burns, et al., "Development Of A Microreactor For Chemical Production", Trans IChemE, Vol. 77, Part A, (May, 1999), pgs. 206-211

Examiner	Alexander	Date Considered	9/8/04

* EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.